

# \*\*\* 1<sup>st</sup> Annual Student Poster Exhibition \*\*\*

of the Northern California Chapter of the AVS

February 23, 2011

## Call for Student Posters



Northern California Chapter of the AVS (NCCAUS) announces the call for abstracts for the 1<sup>st</sup> Annual Student Poster Exhibition in conjunction the 32<sup>nd</sup> Annual Equipment Exhibition to be held on Wednesday, February 23, 2011 at the Wyndham San Jose Hotel, 1350 North First Street, San Jose, CA 95112.

The NCCAUS is affiliated with four users groups: Chemical Mechanical Polishing, Junction Technology, Plasma Applications, and Thin Films. The joint technical session being given by the User Groups will focus on Photovoltaic Energy Technology. **Areas of interest for student posters include surface science, thin films, adhesion, electronic materials, optical coatings, vacuum metallurgy, plasma technologies, nanometer structures, energy technologies, and other areas of vacuum-related science and technology.**

The poster session is open to any student with appropriate material that they wish to present. To encourage participation, we will award a cash prize to the top rated poster. The posters will be judged on their technical merit and the presentation of the results.

### **Abstract Submission Deadline: January 21, 2011**

Please submit a one page abstract via e-mail to:  
Della Miller, [della@avs.org](mailto:della@avs.org)

NCCAUS  
110 Yellowstone Dr., Suite 120  
Chico, Ca 95973  
Tel: 530-896-0477; Fax 530-896-0487



You will receive acknowledgement of receipt of abstract plus instructions for presenting the poster.

➤ **Complimentary (1-year) AVS Student Memberships awarded to all verified student poster presenters!**

➤ **FREE Onsite Registration Required: Exhibit, User Group Meeting and Poster session are all free to attend and includes buffet lunch (12-1pm) and evening reception (5-6pm).**